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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jeng H. Hwang et al.

SERIAL NO.: 09/421,467

FILED: October 19, 1999

FOR: MASKING METHODS AND ETCHING
SEQUENCES FOR PATTERNING ELECTRODES
OF HIGH DENSITY RAM CAPACITORS

§ GROUP ART UNIT: 1756
§ (Parent Application)
§
§ EXAMINER: N. Barreca
§ (Parent Application)
§
§ Attorney Docket No.:
§ AM-2602.C1

Date: January 24, 2002

PRELIMINARY AMENDMENT "A"

Hon. Commissioner for Patents
Washington, DC 20231

Sir:

This Preliminary Amendment "A" accompanies a continuation application of U.S. Application
Serial No. 09/421,467, filed October 19, 1999.

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper and any documents said to accompany this paper are being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. EU092830426US in an envelope addressed to the: Commissioner for Patents, Box Patent Application, Washington, DC 20231.

Date: January 24, 2002

Shirley L. Church

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